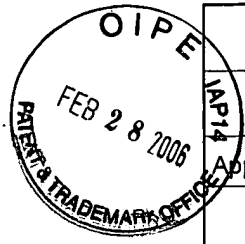
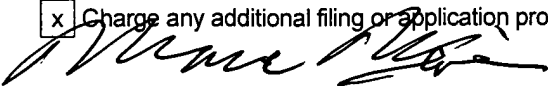


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AMENDMENT TRANSMITTAL LETTER				Docket No. 1691-0177PUS2	
Application No. 10/809,398-Conf. #07540		Filing Date March 26, 2004		Examiner M. J. Song	
				Art Unit 1722	
Applicant(s): Hiroyuki FUKUYAMA et al.					
Invention: SINGLE CRYSTALLINE ALUMINUM NITRIDE FILM, METHOD OF FORMING THE SAME, BASE SUBSTRATE FOR GROUP III ELEMENT NITRIDE FILM, LIGHT EMITTING DEVICE AND SURFACE ACOUSTIC WAVE DEVICE					
MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	2	- 23 =		x	
Independent Claims	1	- 3 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Marc S. Weiner Attorney Reg. No.: 32,181 BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Road Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8000				Dated: <u>February 28, 2006</u>	



PATENT
1691-0177PUS2

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki FUKUYAMA
Appl. No.: 10/809,398 Group: 1722
Filed: March 26, 2004 Examiner: Song
For: SINGLE CRYSTALLINE ALUMINUM
NITRIDE FILM, METHOD OF FORMING THE
SAME, BASE SUBSTRATE FOR GROUP III
ELEMENT NITRIDE FILM, LIGHT EMITTING
DEVICE AND SURFACE ACOUSTIC WAVE DEVICE

AMENDMENT UNDER 37 CFR 1.116

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313

February 28, 2006

Sir:

The following Amendments and Remarks are respectfully submitted in connection with the above-identified application in response to the Official Action of November 29, 2006.

Claim 1 is amended.

Claim 3 is canceled.